

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Eric Bornstein
Application Serial No.: 10/776,106
Filing Date: 11 February 2004
Title: NEAR INFRARED MICROBIAL ELIMINATION LASER
SYSTEM
Examiner: Joyner, Kevin
Art Unit: 1744
Atty. Docket No.: 072287-0020
Confirmation No.: 2676

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, or facsimile transmitted (571-273-8300) to the USPTO, on the date indicated below.

Date: 23 August 2007


Erin Olson

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT - ELECTION

This paper is in response to the Office Action dated 16 May 2007, with included restriction requirement, for the above-identified application. The Applicant requests that subject application be amended in accordance with the following:

- **Amendments to the Claims**, as listed in the listing of claims beginning on page 2 of this paper; and
- **Remarks**, beginning on page 13 of this paper.

A Petition for Extension of Time (three months) under 37 CFR § 1.136 is included with this paper.